



MMS2018 - Delegate Member Biography Form

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|----------------|--|-------------|---------------------|
| First Name | Takashi | Last Name | Mihara |
| Title/Position | Director General of MEMS Industry Forum | Affiliation | Micromachine Center |
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| Biography | Photo |
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| <p>Takashi Mihara received his MS degrees in physics from Tokyo University of Science, Japan in 1981. He worked on high speed bipolar devices and ultra-high-speed ECL memories for super computer at Hitachi LSI systems Corp. Since 1988, he worked on versatile BiCMOS with V-PNP, fatigue-free ferroelectric memories, and chemical sensor system using MEMS microcantilever in Olympus Corp. Now he is a Director General of MEMS Industry Forum, and MNOIC Strategy Planning Dept. Micromachine Center in Japan. He received the Ph. D. degree in Electrical Eng., in 1996.</p> |  |
| | <p>Logo of the Institution</p> |
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